

## Fabrication and Characterization of Nano MgO Crystal

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**Abstract:** In this work, the direct precipitation method was used to generate magnesium salt Mg(OH)<sub>2</sub>, the process of preparing MgO crystal by calcining Mg(OH)<sub>2</sub> in three stage temperature was studied, and MgO crystal was characterized by scanning electron microscope and XRD. On this basis, the energy band structure and states density of Mgo crystal were calculated by the first principle theory, the influence of crystal orientation on Mgo secondary electron emission was analyzed. The experimental results show that the MgO prepared by this method is cubic crystal. The grain size is evenly distributed in the vicinity of 40.65nm. The crystal orientation is of (200), (111), (220) and along the (200) orientation preferential growth.

**Keyword:** MgO Crystal, Secondary Electron Emission, First Principle theory, Direct Precipitation Method

### Introduction

MgO is a kind of metal oxide material, which has capacities of good insulation, chemical inertness and sputtering resistance. Since MgO has the factors of high coefficient of secondary electron emission, stable working performance, can withstand high current density, craft process simple, it is widely used as materials secondary electron emitter. It is important component of optoelectronic detecting instruments and flat panel display devices [1]. In the related research field, MgO can be used as the dielectric protective film material of the gas discharge device[2], and the improvement of the surface electron emission ability has become the key factor to improve the luminous efficiency of the device [3][4]. It is important to study the preparation technology of MgO material in high Xe environment, which can increase the number of secondary electron emission on the surface of MgO material and improve the luminous efficiency of the device [5].

But there are some problems come out with the increase of Xe content in the working gas of MgO, such as the increase of discharge delay and the decrease of the response speed of the device. Kim et al. study on the effects of the exo-electron on MgO materials for addressing speed, put forward by increasing the number of the exo-electron methods to improve addressing speed [6]. Because of the high specific surface of nano MgO crystal by using microcrystalline particles, the exo-electron emission quantity will be improved, the speed of electron emission will be accelerated, the discharge delay time will be reduced, the stability of discharge will be improved. Therefore, it is very important to fabricate the high purity and consistency MgO particles for improving the electron emission characteristics of optoelectronic devices.

In this paper, the microstructure of MgO crystal was studied, and the precursor of MgO was prepared by low cost liquid phase synthesis method. The preparation process of nano MgO crystal material was explored, which could guide the preparation of MgO material. The related research has

a theoretical and practical significance for understanding the relationship between the microstructure of MgO materials and the electron emission coefficient.

### Theory of MgO exo-electron emission

General MgO primitive cell model could consult Sasaki's studies [7]. According to the reference, MgO has the same cubic cell structure as NaCl, which belongs to the space group FM-3M. Standard MgO model contains 14  $Mg^{2+}$  and 13  $O^{2-}$ , shown as Fig 1

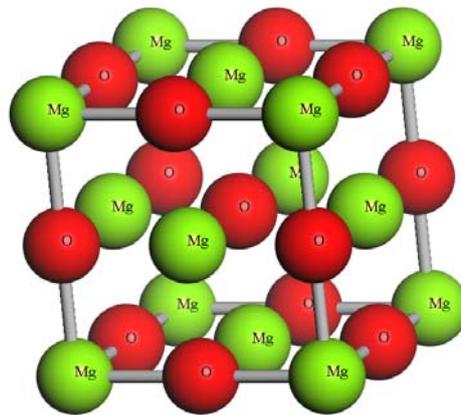


Fig. 1 Nano MgO primitive cell model

Inside nano MgO, the relaxation of electrons and holes, composite process that is captured by the forbidden band of electron in absorbing composite process of energy released from the surface of the MgO style after injection. This escape electron emission belongs to MgO material itself or into electrons and holes of MgO style after a slow delay compound produced by the electron emission. The main processes of escape electron emission of nanometer MgO style crystal are:

- 1) Electron irradiation in vacuum ultraviolet or electron collision excitation to the conduction band;
- 2) Shallow hole level can capture these electrons;
- 3) Captured through thermal excitation effect to be excited to conduction band again, and after drift in MgO style crystal, was captured by the hole again;
- 4) Radiation centers capture some electronic drift;
- 5) Electron in the band gaps by VUV irradiation or auger effect to the excitation energy to the discharge space form the run-up to erase the wall charges required.

Cathode electron excitation spectra showed that nano MgO crystal material itself has an oxygen defect in MgO crystal and a broad peak related to near 400 nm wavelength. Single crystal MgO particles in electron and ultraviolet photon excitation, will have two peaks near 400 nm and 235 nm. The emission peaks exist in single crystal MgO particles, and luminous summit increases will increase with the size of MgO single crystal. The emission peak is mainly composed of the Auger recombination process of electron and hole in the composite produced by 235nm (5.3eV) VUV. In the single crystal MgO, the hole and electron recombination process, which can make the electrons in the forbidden band escape into the discharge space, can enhance the electron emission properties of the MgO materials

Therefore, Yan team [9][10] and Chiang[11] and others believe that the existing electronic single crystal MgO nano particles in the composite hole trap can produce desired electron and hole. Nano MgO crystal coating on the surface of MgO film, can increase the exo-electron emission surface, improve the low bit delay, improve the discharge stability. The preparation of nano MgO has an important significance for improving the photoelectric properties of MgO materials.

## Fabrication method of nano MgO crystal

The preparation of MgO nano particles with high purity was divided into MgO precursor preparation and MgO crystal preparation. In this paper, the precursor  $Mg(OH)_2$  was prepared by direct precipitation method, and the MgO crystal was prepared by calcination method [12].

### Fabrication of $Mg(OH)_2$

Morphology of prepared MgO precursor  $Mg(OH)_2$  was influence on the following morphology of MgO crystal in a certain extent. The precursor crystal morphology, size and crystal orientation related by the technics of preparation. It is necessary to consider the process parameters in the preparation process.

The experiment mainly adopts magnesium salt  $C_4H_6O_4Mg \cdot 4H_2O$ , using NaOH as precipitant, selection of ethylene glycol as dispersing agent, to preparation of  $Mg(OH)_2$ . The experiment was prepared by direct precipitation method, mainly studied in the process of preparation of magnesium salt and precipitant concentration on precursor shape looks and the influence of particle size.

When the precipitant concentration increased from 0.25M to 1.25M, the reaction in direct precipitation under ultrasonic condition, the  $Mg(OH)_2$  shape changed from flake into rod gradually. When the initial concentration of magnesium salt increased from 0.4M to 0.8M, the  $Mg(OH)_2$  particle size increases gradually, grain boundaries become blur, shown in Fig. 2.

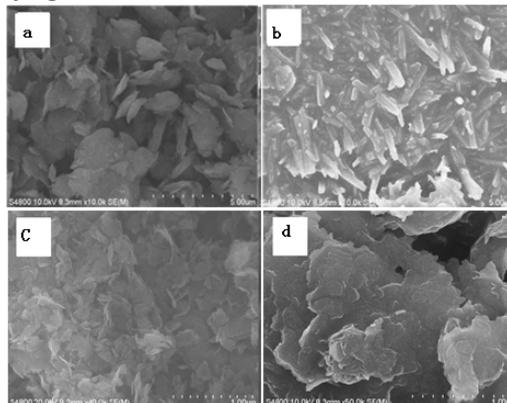


Fig.2 Photos of Different preparation magnesium hydroxide precipitant and the initial concentration of magnesium salt SEM (a: precipitation agent 0.25M; b: precipitation agent 1.25M; c: magnesium salt 0.4M; d: precipitation agent 0.8 M)

The reasons affecting the reactant concentration on the morphology and size of the precursor body are: there are two stages nucleation and grain growth of grain growth. If the concentration of reactants is too low, it is difficult to form a large number of homogeneous nucleation, grain will growth on the nucleation which has been formed priority, which makes easy to get great number of grain. When the concentration of reactants is too high, crystal nucleation rates greater than the growth rate, add with reactants produce a large number of crystal nucleus instantly, nucleus grew up too late, so the surface free energy is very high, it is easy to agglomerate. Therefore, when the precipitant concentration of  $Mg^{2+}$  is relatively large at the beginning time, degree of super saturation is great, and the nucleation rate is greater than the growth rate, it is easy to get small solids precipitation. But when the nucleation density is too large, it will lead to the blurring of the boundaries between the grains.

### Fabrication of nano MgO crystal

MgO was prepared by three stage calcination heating process, and the MgO crystal was prepared by calcination of  $Mg(OH)_2$  with temperature control, and the calcination process can be described as formula (1).



In response, in order to ensure the crystal morphology and grain size of MgO crystal, the calcination process of experiment in environmental samples under nitrogen atmosphere, heating up to 1350°C, the heating rate is 5°C/min, and set the temperature control heating curve according to the TG standard drawing precursor.

There are three heating temperature control curve, corresponding to the sample area. The multi segment weight loss, weight loss rate of sample temperature peak occurred at 340~427°C, the temperature of the sample. The weight loss rate is 20.82%. High loss rate showed that Mg(OH)<sub>2</sub> is under this temperature decomposition. In addition, the weight loss of 355°C belongs to the decomposition of organic matter caused by weightlessness temperature near the point of 709.3~778.2°C also has 10.07%. Since then, the highest temperature point control reaction heat treatment at 1156°C, can reduce the surface defects of crystal grain, and the grain size of material, crystal etc. Finally, when the temperature rises to 1346.5°C, the residual MgO mass is about 62.62%, and the specific process is shown in Fig. 3.

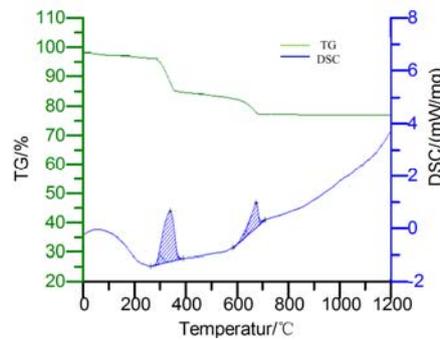


Fig 3 Mg(OH)<sub>2</sub> calcined hot weight standard

In the calcination experiments, The morphology of precursor can extent affect the shape of MgO style after calcining, flake of precursor will become cube morphology of MgO after calcining, rod-shaped precursor still keeps stick style of MgO after calcination. This is mainly because the precursor sheet can provide a good atmosphere, calcination process of crystallization is more uniform. And for the long rod precursor, crystal growth will be preferred in some direction in calcination.

In addition, the pretreatment of precursor will also affect the purity of crystal MgO. The Mg(OH)<sub>2</sub> was cleaned and purified several times, and the experimental results show that the increase in the number of cleaning will removing impurities and increase the purity of nano MgO crystal, shown in Tab 1.

Tab1 The purity of MgO prepared by different processing

Processing	Content of elements in MgO (%)				
	C	Na	Si	S	Ca
Clearing 5	0.32	0.014	0.03	0.014	0.026
Clearing 7	0.2	<0.005	0.0070	0.010	0.0050

### Character of nano MgO Crystal

The MgO crystal was analyzed by scanning electron microscopy (SEM), and it is found that sheet Mg(OH)<sub>2</sub> will formed cube structure MgO crystal powder after calcined. The crystallization and grain size of the powder is with expectations, as shown in Fig 4.

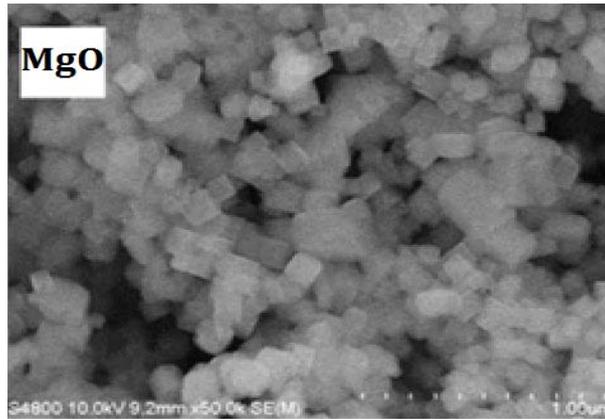


Fig.4 SEM of MgO formed by calcination of sheet Mg(OH)<sub>2</sub>

The analysis of crystal X-ray diffraction (XRD) preparation showed that the test data are fit the date of standard cubic test card (JCPDS87-0653 space groups Fm 3m). Under the condition of the corresponding process, the powder of MgO style is cube structure, the grain size at  $2\theta=36.937^\circ$ ,  $42.917^\circ$ ,  $62.304^\circ$ ,  $74.691^\circ$ ,  $78.630^\circ$  appear diffraction peaks at (111), (200), (220), (311), (222), the diffraction peak is sharp, except for slight instrument test migration, no phase diffraction peaks exist. The results show that the MgO crystal has high purity, good crystallinity and crystal growth along (200), and the results are shown in Fig 5.

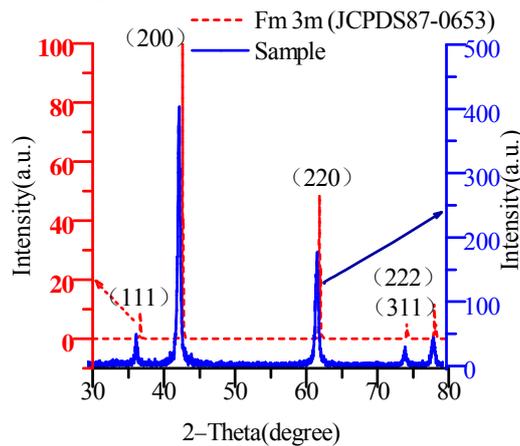


Fig.5 XRD test results of nano crystalline MgO structure

Get MgO data obtained by the above XRD test into the Scherrer formula, you can estimate the size of the grain, shown in Figure (2).

$$D = \frac{K\lambda}{\beta \cos \theta} \quad (2)$$

In the formula, the constant K is 0.943, D is the average thickness of the grain is perpendicular to the plane direction,  $\beta$  is the half height breadth of the samples' diffraction peaks,  $\theta$  is diffraction angle, X-ray wavelength is 0.154056 nm.

From the results of this experiment,  $\beta$  is 0.22 nm,  $\theta$  is  $21.46^\circ$ , estimated grain size is 40.65nm. As described in the reference, the results which MgO style is cubic grain and the grain size distributed in the range of 50nm are approximate.

## Conclusion

Nano MgO crystal has the larger specific surface area, the higher the exo-electron emission characteristics, It has wider application. The preparation of MgO precursor using low cost solution,

and the calcination process of preparation of MgO is an important method for the preparation of MgO crystal.

The Mg(OH)<sub>2</sub> was prepared by direct precipitation in this article, the multistage calcination temperature control sheet was adopted to prepare MgO style crystal precursor, finally got MgO crystal orientation at (111), (200), (220), (311), (222). Experimental results show that the crystal orientation selective extension at (200), grain size is 40.65nm, showing a high degree of crystallinity.

### **Acknowledgment**

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